

MEMS Engineer Forum 2026

SMART Society Driven by MEMS

April 21-22, 2026

KFC Hall, Ryogoku, Tokyo, Japan

Free charge for conference and exhibition

EXHIBIT Guidance

<http://www.m-e-f.info/>

| Exhibits Type and Benefit (10% tax to be added) | Regular Exhibit | Academic Exhibit | Start-up Exhibit |
|--|-----------------|------------------|------------------|
| | ¥300,000 | ¥60,000 | ¥60,000 |
| 1 Short Presentation (4-min) | ○ | × | ○ |
| 2 Advertisement in digital MEF Program Handout | A4 Full page○ | A4 Full page○ | A4 Full page○ |
| 3 Logo on MEF Website | ○ | ○ | ○ |
| 4 Logo on MEF Sign board | ○ | ○ | ○ |
| 5 1-min PR Movie Run at breaktime (main hall) | ○ | × | ○ |
| 6 Invitation ticket(s) to Networking event (Apr. 16) | 1* | × | × |
| 7 Lunch ticket(s) (Apr.16&17) | 2* | × | × |
| 8 Meeting room usage | ○ | ○ | ○ |
| 9 Registration List (limited only accepted) | ○ | × | × |

*If you apply by January 31, 2026, you will get double benefit for the columns with *.

MEF International Advisory Committee

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Keiichi Umeda/Murata Manufacturing Co., Ltd.
Hiroyuki Wado/MIRISE Technologies
Yoko Yamanishi/Kyushu University



Speakers for MEF 2026

By alphabetical order of last name

Palvi Apilo, TactoTek, Finland
Pierre Damien Berger, CEA LETI, France
Matthijn Dekkers, Lam Research, USA
Stefan Ernst, Xfab, Germany
Weiliun Fang, National Tsing Hua University, Taiwan
Tino Fuchs, Robert Bosch GmbH, Germany
Suryaprakash Ganti, Frore Systems, USA
Kazuyuki Higashi, NuFlare Technology, Inc., Japan
Shigeto Iwai, Yokogawa Electric Corp., Japan
Jerome Mouly, Yole Group, France
Hiroshi Suzuki, Syntiant Japan K.K., Japan
Mika Takahashi, IDtechEx, U.K.
Patrick Turner, Resonant Inc., a Murata Company, USA
Yao Zhu, Agency for Science, Technology and Research (A*STAR), Singapore
TBA, QST Corporation Limited, China

More speakers are coming.....

Regular Booth

Booth size: W1800mm × D900mm × H2100mm
(Height of table: 700mm)

The following items are included in the booth.

- Back panel
- Affiliation Name Board (standardized design)
- Electric outlet 500W (2 outlets)
- Table and Chair

Academic and Start-up Booth

Booth size: W1800mm × D450mm × H1800mm
(Height of table: 700mm)

The following items are included in the booth.

- Back panel
- Affiliation Name Board (standardized design)
- Table and Chair

Electric outlet 500W (2 outlets) is optional at 6,600 JPY (tax included)

MEF 2026 Secretariat
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